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MDP 6/13/6

Response to office action of April 24, 2006 for appl. no. 10/670,673



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wachtmann

Atty. Docket: 2550/185

Serial No.: 10/670,673

Art Unit: 2814

Filing Date: September 25, 2003

Invention: METHOD OF FORMING A  
SURFACE MICROMACHINED  
MEMS DEVICE

Examiner: Pizarro Crespo, Marcos D

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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 25, 2006.

  
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John L. Conway

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE E**

Dear Sir:

In response to the Office Action mailed on April 24, 2006 and made final,

Applicant responds as follows: